



Title: PLASMA SEMICONDUCTOR PROCESSING SYSTEM AND METHOD
Inventors: Tue Nguyen and Dung Nguyen
Application No.: 09/898439
Docket No.: TEGL-01165US0
Attorney: Charles H. Jew

Filing Date: July 5, 2001
Art Unit: 2818
Telephone No. (415) 362-3800

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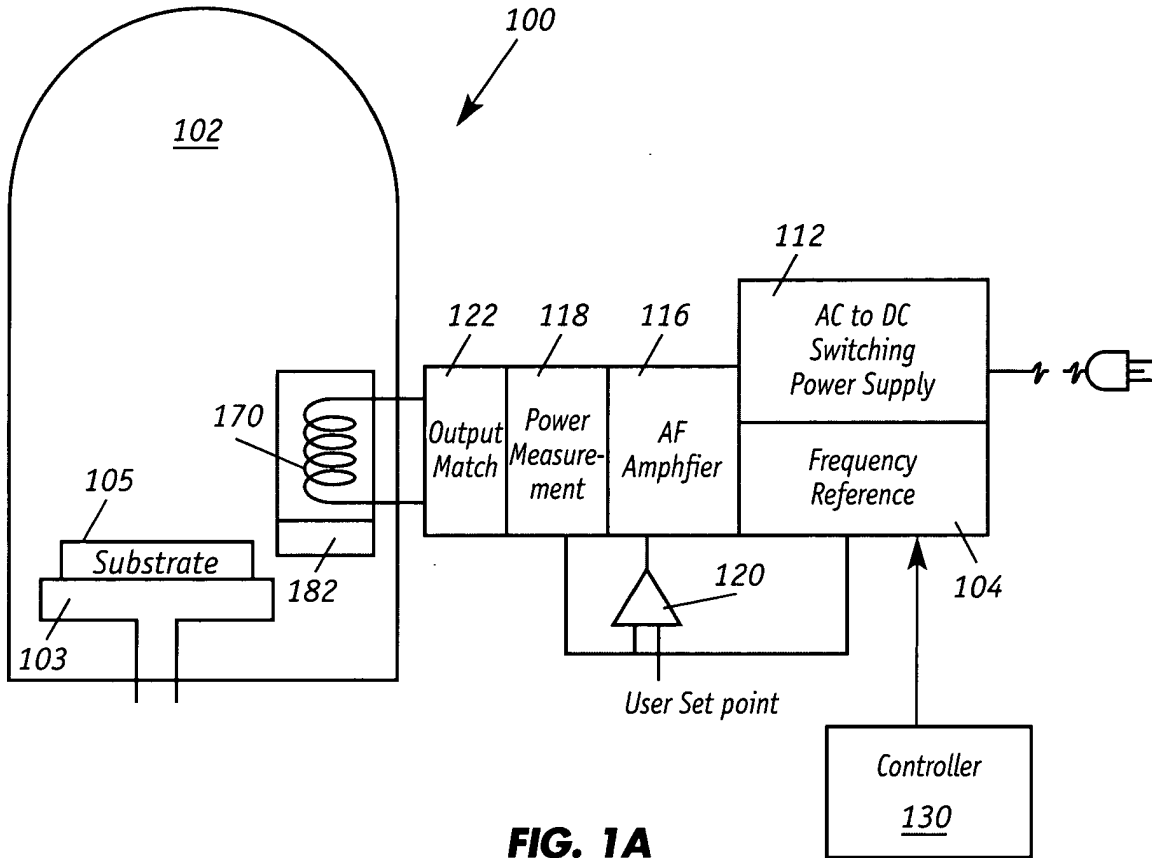


FIG. 1A

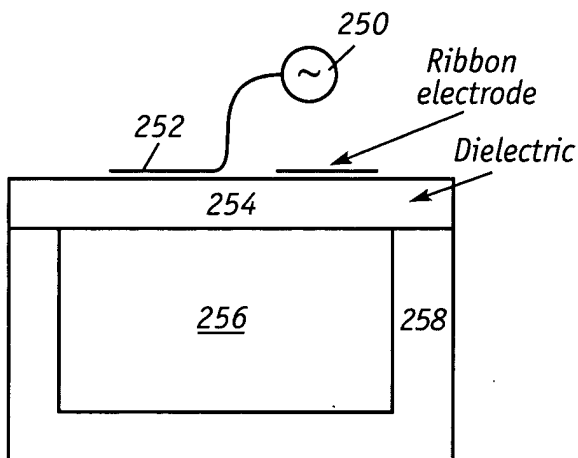


FIG. 1B

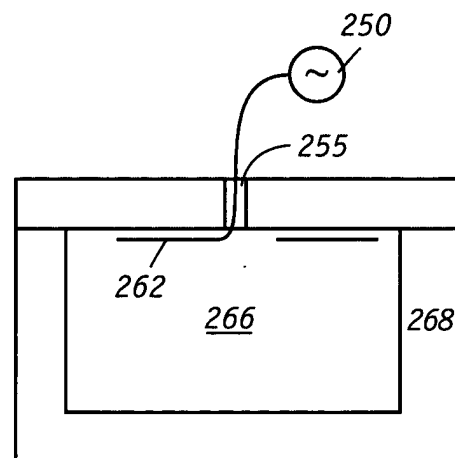


FIG. 1C



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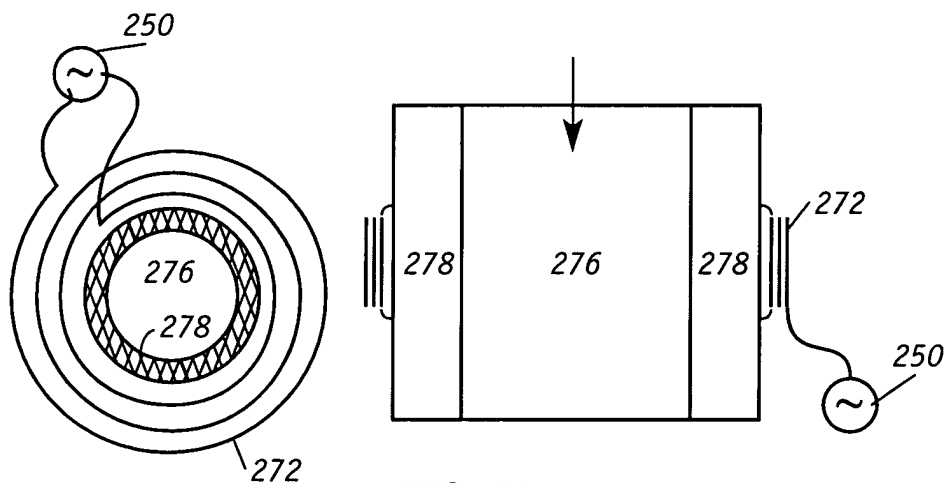


FIG. 1D

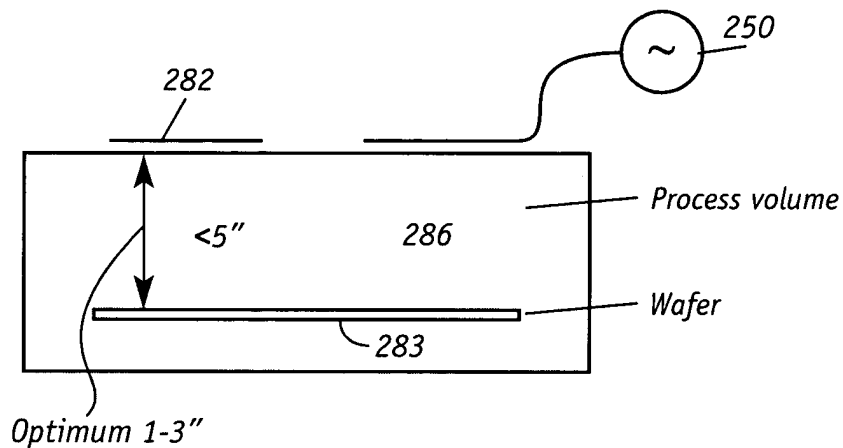


FIG. 1E

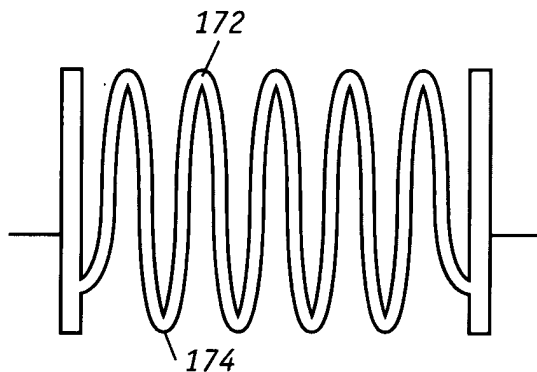


FIG. 2A



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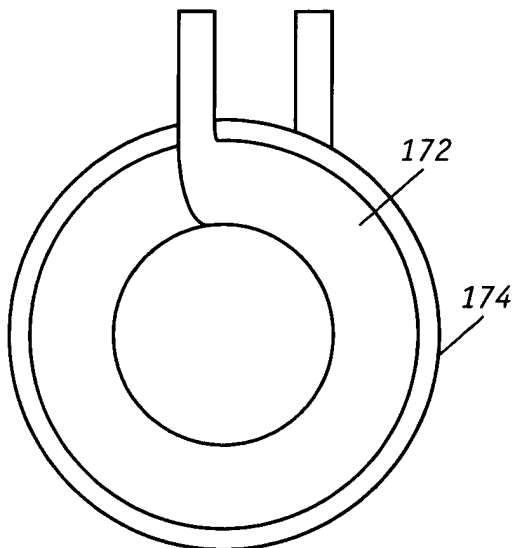


FIG. 2B

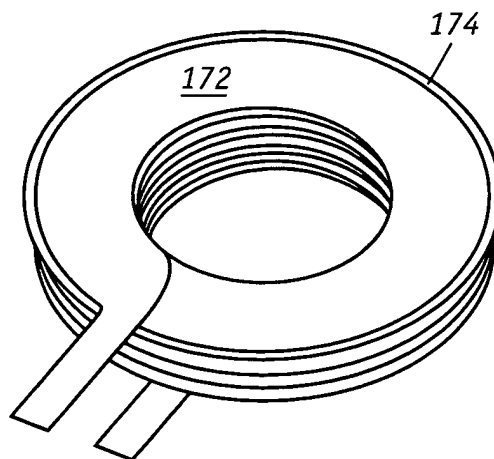


FIG. 2C

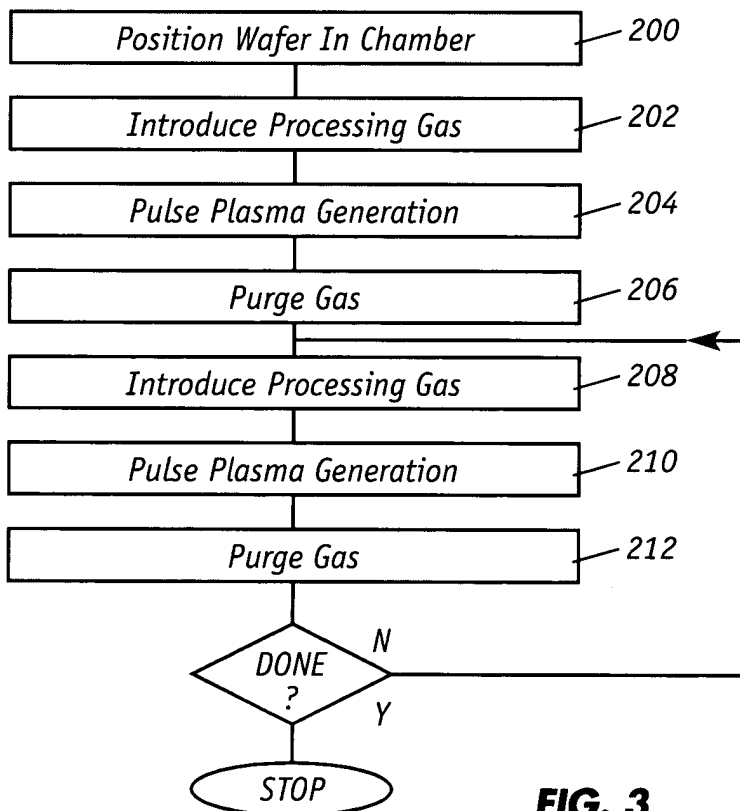
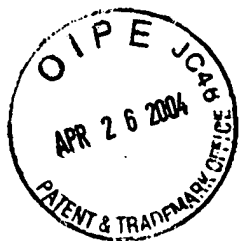


FIG. 3



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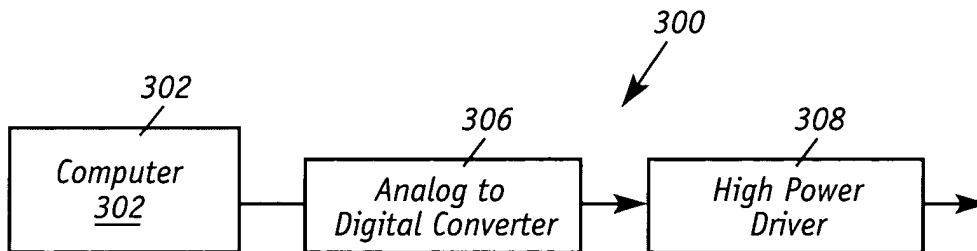


FIG. 4A

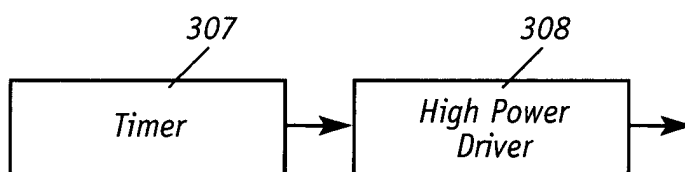


FIG. 4B

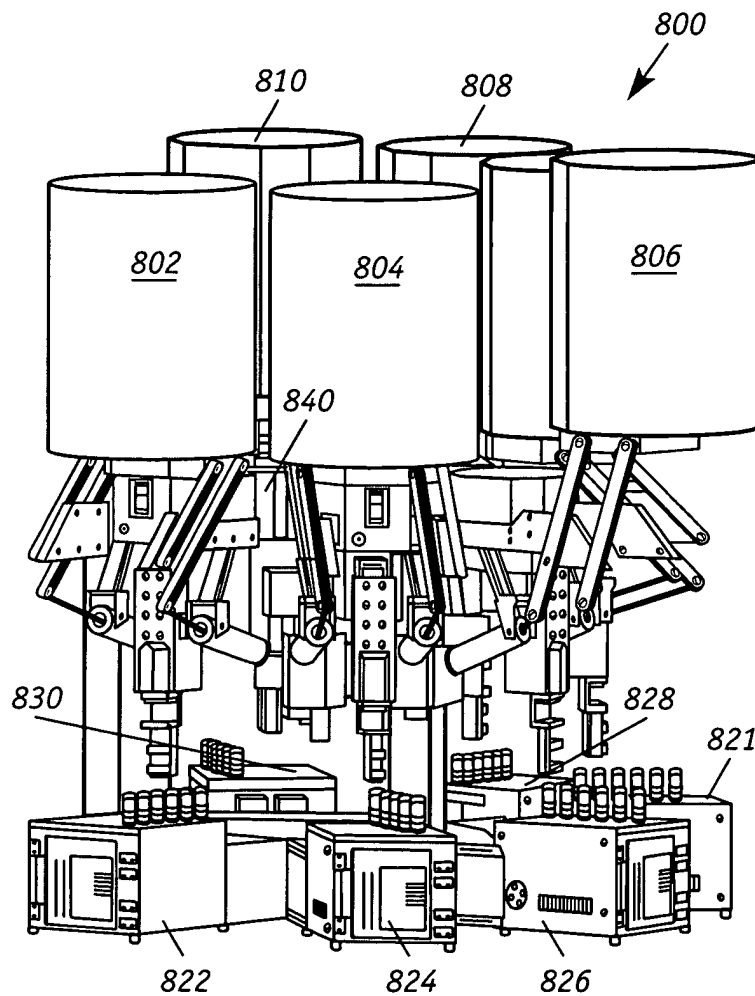


FIG. 5



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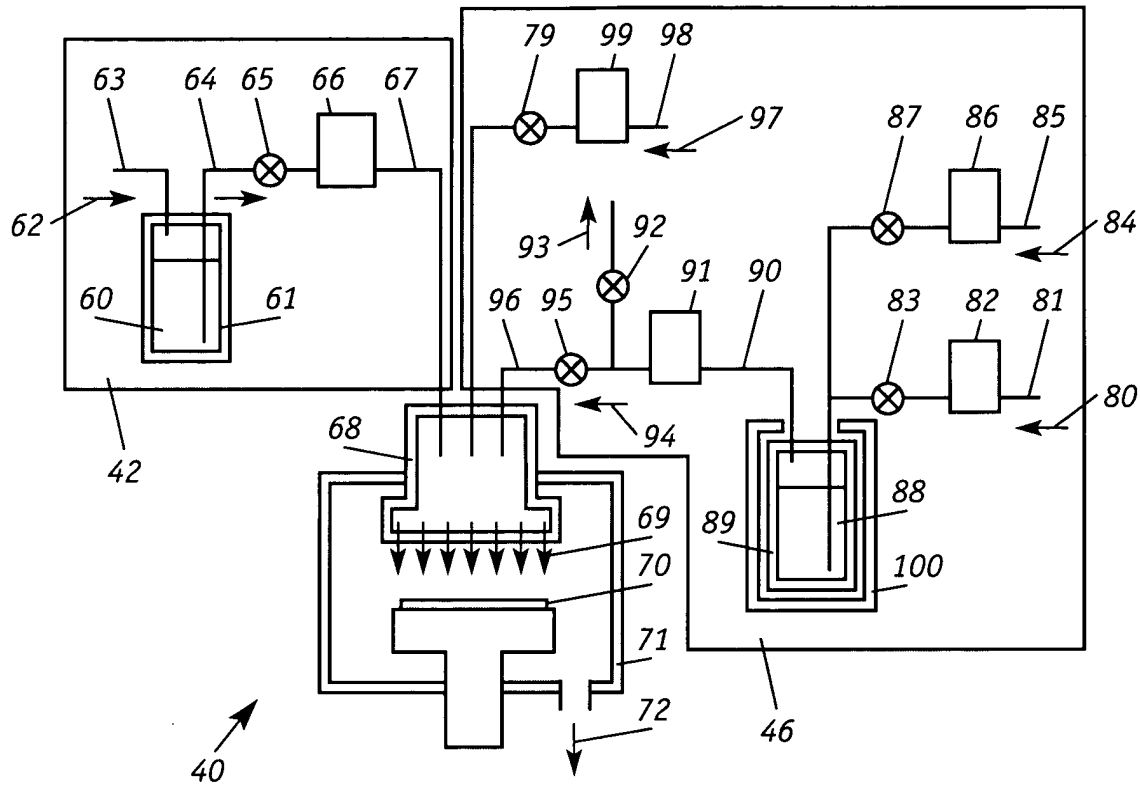


FIG. 6

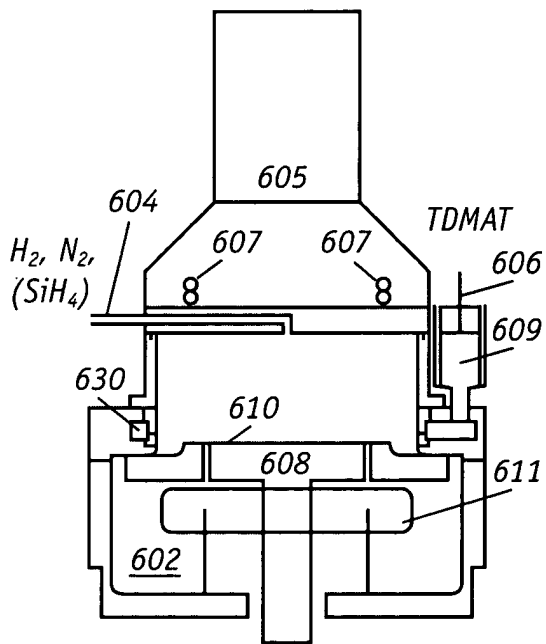


FIG. 7A

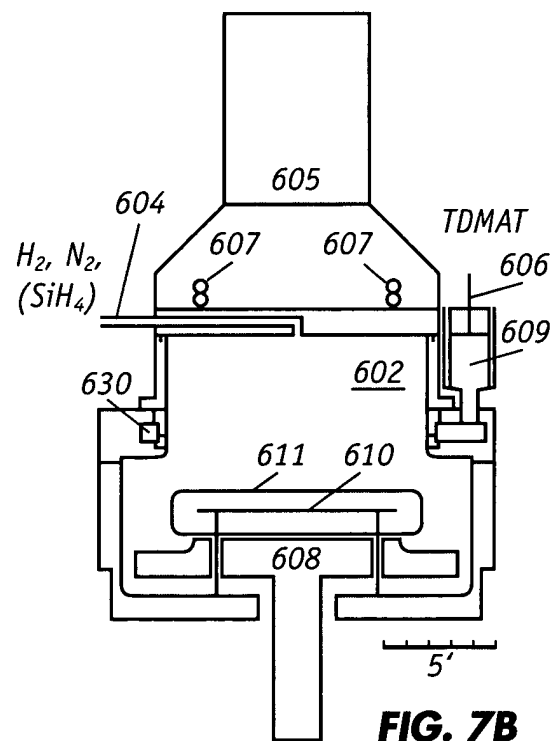


FIG. 7B